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Capacitance-voltage modeling of metal-ferroelectric-semiconductor capacitors based on epitaxial oxide heterostructures

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We report a quantitative investigation on the capacitance-voltage (C-V) modeling of metal-ferroelectric-semiconductor epitaxial heterostructures based on a theoretical model. Within the carrier concentration between $10^{17}$ and $10^{21} \text{ cm}^{-3}$, calculated C-V curves were consistent with measurements exhibiting from a significant asymmetry to a typical butterfly shape resembling that of a metal-ferroelectric-metal capacitor. The behavior of the C-V curves can be understood by the width of the depletion region and the extent of the depolarization field. These results suggest that quantitative understanding on the electrical behavior of oxide heterostructures is possible with C-V measurements with potentially important implications on their device applications. © 2011 American Institute of Physics. [doi:10.1063/1.3561751]

Epitaxial oxide heterostructures are of great interest since the diverse properties of oxides and oxide superlattices can offer attractive possibilities for various device structures. Special emphasis has been put on ferroelectric-semiconductor heterostructures, which permit nonvolatile memory elements with nondestructive readout, sensors, and tunable microwave devices. While the modulation of semiconductor conductivity by ferroelectric polarization has been investigated in several oxide systems such as Pb(Zr,Ti)O$_3$ (PZT)/(La,Ca)MnO$_3$ (LCMO), or PZT/ZnO, little attention has been given to their capacitance-voltage (C-V) characteristics. Unlike a silicon-based metal-ferroelectric-insulator-semiconductor (MFS) structure, for which quantitative models have been developed to describe its C-V behavior, no quantitative analysis on the C-V measurement has been reported so far for the metal-ferroelectric-semiconductor (MFS) epitaxial oxide heterostructures. In some cases, the measured C-V curve of the MFS structure exhibited the typical butterfly shape observed in a metal-ferroelectric-metal (MFM) capacitor. However, in other cases, the shape of C-V curves was so asymmetrical that neither the MFM nor the MFS model could adequately describe its behavior. Furthermore, lack of quantitative understanding precluded the C-V measurement of the oxide heterostructure from providing valuable insight into the electrical properties, such as the carrier concentration in the semiconducting oxide, the width of a depletion layer, or the density of interface traps. In this study, we therefore attempt to deliver a quantitative modeling on the C-V characteristics of an MFS capacitor based on an epitaxial oxide heterostructure. We investigate C-V characteristics obtained by a simulation to demonstrate the feasibility of using the C-V measurement as a tool of understanding and predicting the electrical behavior of the MFS epitaxial oxide heterostructure.

The MFS structure for the analysis is shown in Fig. 1(a) along with a simple equivalent circuit. The theory and the technique for the simulation are based on the model developed by Miller and McWhorter. However, unlike their model, a semiconductor oxide (p-type) is used instead of silicon and no insulating layer exists between the ferroelectric and the semiconductor. If the flat band voltage is assumed to be zero and the interface trap density is negligible, the gate voltage $V_g$, divided between the semiconductor and the ferroelectric, is given by

$$V_g = \phi_s - \frac{(Q_s + P(E_{FE}))d_{FE}}{\varepsilon_0\varepsilon_{FE}},$$

where $\phi_s$, $Q_s$, $P(E_{FE})$, $\varepsilon_0$, $\varepsilon_{FE}$, and $d_{FE}$ are the surface potential, the surface charge in the semiconductor, the ferroelectric polarization as a function of the electric field, the permittivity of free space, the linear dielectric constant of the ferroelectric, and the thickness of the ferroelectric, respectively. The electric field in the ferroelectric layer is given by

$$E_{FE} = -\frac{(Q_s + P(E_{FE}))}{\varepsilon_0\varepsilon_{FE}}.$$

If the semiconducting oxide is assumed to follow the conventional band description, the surface charge of the semiconductor $Q_s$ is given as a function of the surface potential $\phi_s$ by

![FIG. 1. (a) Schematic cross-section of the MFS capacitor along with an equivalent circuit. (b) The saturated hysteresis loop of ferroelectric polarization as a function of the electric field.](image-url)
The derivative of the polarization spontaneous polarization, the remanent polarization, and the coercive field, respectively. The derivative of the polarization

$$Q_s(φ_s) = -Sgn(φ_s)\sqrt{2\varepsilon_P}\frac{ε_P}{βL_B}\left(e^{-βφ_s} + βφ_s - 1\right)$$

$$+ \left(\frac{n_i}{N_s}\right)^2 \left(e^{βφ_s} - βφ_s - 1\right)^{1/2},$$

where $Sgn(φ_s)$ is the sign of $φ_s$, $ε_s$ is the dielectric constant of the semiconductor, $N_s$ is the carrier concentration, $n_i$ is the intrinsic carrier concentration, $β = q/kT$ ($q$: unit charge, $k$: Boltzmann’s constant, and $T$: temperature), and the Debye length $L_B$ is given by $(ε_0ε_s/βqN_s)^{1/2}$. The total capacitance per unit area of the MFS structure $C_{total}$ is given by $^{14}$

$$C_{total} = (C_s^{-1} + C_{FE})^{-1},$$

where the capacitance per unit area of the semiconductor $C_s$ is given by $^{14}$ $C_s = -dQ_s/dφ_s$ and the capacitance per unit area of the ferroelectric layer $C_{FE}$ is given by $^{9} C_{FE} = -d(Q_s + P)/dV_g = (ε_0ε_sP_s + dP/dE_{FE})/dφ_s$. When the function $P(E_{FE})$ is known, Eqs. (1)–(4) completely describe the capacitor operation of the MFS structure in Fig. 1(a). $^{9,14}$ It needs to be mentioned that $C_{FE}$ in the above equation is valid at a low frequency while the MFS capacitor curves are typically measured at a high frequency. Hence, $C_s$ will be constrained at its minimum value in depletion for the simulation.

The saturated polarization hysteresis loop shown in Fig. 1(b) can be expressed by $^{9}$ $P_{sat}(E_{FE}) = P_s tanh[(E_{FE} - E_s)/2δ]$ for the positive-going branch and $P_{sat}(E_{FE}) = P_s tanh[(E_{FE} + E_s)/2δ]$ for the negative-going branch, where $δ = E_s ln[(1 + P_s/E_s)/(1 - P_s/E_s)]$ and $P_s$, $E_s$, and $E_{c}$ correspond to the spontaneous polarization, remanent polarization, and coercive field, respectively. The derivative of the polarization is given by $^{9}$

$$\frac{dP}{dE_{FE}} = \Gamma \frac{dP_{sat}}{dE_{FE}},$$

where $\Gamma = 1 - tanh[(P - P_{sat})/(ξP_s - P)]^{1/2}$ and $ξ = 1$ when $dE_{FE}/dt > 0$ and $ξ = -1$ when $dE_{FE}/dt < 0$. $P(E_{FE})$ can then be obtained by integrating Eq. (5) with the sequence developed by Miller and McWhorter. $^{9}$ Once $P(E_{FE})$ is obtained, $C_{total}$ can also be calculated as a function of $V_g$ by Eq. (4). The parameters used to perform the analysis were $ε_c = 100$ kV/cm, $P_s = 2$ μC/cm$^2$, $P_r = 1.33$ μC/cm$^2$, $d_{FE} = 400$ nm, $ε_{FE} = 130$, $N_s = 10^{17} - 10^{21}$ cm$^{-3}$, $n_i = 10^{10}$ cm$^{-3}$, $ε_s = 30$, and $T = 300$ K. The initial conditions are $V_g = 0$ and $P = 0$. The applied gate voltage was limited to ±20 V.

The key of describing the capacitor operation, the polarization hysteresis loop as a function of the field in the ferroelectric layer $P(E_{FE})$, is shown in Fig. 2(a) for three different carrier concentrations ($1 × 10^{17}$, $1 × 10^{19}$, and $1 × 10^{21}$ cm$^{-3}$). In contrast to silicon-based MFS capacitors, which exhibit unsaturated hysteresis loops of the ferroelectric polarization, $^{9,11}$ the MFS capacitor based on the semiconducting oxide exhibits a saturated hysteresis loop. The MFS capacitors also exhibit a negligible depolarization field as the semiconducting oxide can fully compensate the ferroelectric polarization. This can be confirmed by the minimal hysteresis in the field in the ferroelectric with respect to gate bias in Fig. 2(b). The negligible existence of the depolarization field allows $P_r$ in Fig. 2(c) to remain almost the same as that of the MFM capacitor. However, as the depolarization effect is pronounced for a semiconductor with lower concentration, $^{15}$ the existence of a minor depolarization field for $N_s = 10^{17}$ cm$^{-3}$ causes slightly reduced $P_r$.

In MFS capacitors, the insulating layer between the ferroelectric and the semiconductor imposes the following electrostatic boundary condition that must be satisfied at the dielectric layer interface, $^{9} ε_0ε_sE_{FE} + P = ε_1E_I$, where $ε_1$ and $E_I$ are the dielectric constant and the field in the insulator;

![FIG. 2. (Color online) Simulation example of (a) $P-E_{FE}$, (b) $E_{FE}-V_g$, and (c) $V_g-E_{FE}$ in the MFS structure for different carrier concentrations (in cm$^{-3}$).](image)

![FIG. 3. (Color online) Simulation example of (a) $P-E_{FE}$, (b) $E_{FE}-V_g$, and (c) $V_g-E_{FE}$ in the MFS structure for $ε_1 = 100$ and $ε_1 = 10$. Results in the MFS structure are also shown for comparison.](image)
respective. Because a typical insulator layer does not provide enough charges to compensate the polarization in the ferroelectric layer, the depolarization field is formed to reduce the ferroelectric polarization (hence, resulting in an unsaturated polarization hysteresis loop). The effect of the insulator layer in the MFIS structure can be seen in Fig. 3, where we calculated the ferroelectric polarization and the depolarization field of the MFIS structure for $e_f=10$ and 100, respectively. In both cases, the insulator is 30 nm thick and $N_d=1\times10^{19}$ cm$^{-3}$. When the insulator layer can compensate the polarization ($e_f=100$), the depolarization field becomes negligible resulting in the saturated polarization. However, the ferroelectric polarization becomes unsaturated when the insulator layer cannot compensate the polarization ($e_f=10$). The clockwise hysteresis loop in Fig. 3(b) clearly shows the formation of the depolarization field.

Figure 4 shows the C-V curves of the MFS capacitor for three different carrier concentrations ($1\times10^{17}$, $1\times10^{19}$, and $1\times10^{21}$ cm$^{-3}$), along with those of the MFIS capacitor. As the maximum width of a depletion layer ($W_{max}$) in a semiconductor is given by $2\varepsilon \varepsilon_0 \varepsilon_f qN_d/\varepsilon \varepsilon_0 qN_d$, $C_S$ becomes unsaturated for typical ferroelectric materials. The result of 1 $\mu$m for typical doping levels ($10^{14}-10^{16}$ cm$^{-3}$) suggests that the contribution of $C_S$ decreases in depletion making the shape of the C-V curves similar to that of the MFM capacitor.

It needs to be mentioned that, for silicon-based MFIS capacitors, $C_{total}$ represents $C_{FE}$ in accumulation and $C_S$ in depletion and inversion. $C_{FE}$ is independent of the voltage in MFIS structures because the polarization hysteresis loop becomes unsaturated for typical ferroelectric materials. The effect of $C_S$ to $C_{total}$ is conspicuous in depletion and weak inversion, as the thick depletion layer, which is on the order of 1 $\mu$m, results in the less conspicuous contribution of $C_S$ to $C_{total}$ in Fig. 4(c) than that in a silicon-based MFIS capacitor. The dominant contribution of $C_S$ to $C_{total}$ cannot be observed until the thickness of the depletion layer becomes comparable with that of silicon in Fig. 4(d).

In summary, we investigated the C-V modeling of MFS capacitors based on epitaxial oxide heterostructures. Unlike MFIS capacitors, MFS capacitors showed saturated hysteresis loops of the ferroelectric polarization as a function of the applied field. The C-V curves based on the Miller-McWhorter model showed good agreements with the measurement reported in literature. Between the carrier concentration of $10^{17}$ and $10^{21}$ cm$^{-3}$, the shape of the C-V curves exhibited a significant asymmetry at low carrier concentrations and it resembled that of the MFM capacitor at high carrier concentrations. These results demonstrate the feasibility of using the C-V measurement as a tool of analyzing the electrical behavior of oxide heterostructures, providing potentially important implications on their device applications.


FIG. 4. (Color online) C-V curves of (a) the MFM capacitors and the MFS capacitors with the carrier concentration of (b) $10^{17}$, (c) $10^{19}$, and (d) $10^{21}$ cm$^{-3}$ in the semiconductor. As the carrier concentration increases in the MFS structure, the contribution of $C_S$ decreases in depletion making the shape of the C-V curves similar to that of the MFM capacitor.